

INFORMATION DISCLOSURE STATEMENT  
PTO-1449 (PAGE 1 OF 1)

SERIAL NUMBER 10/698,433

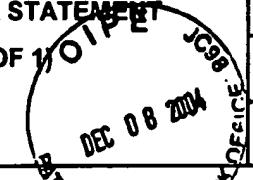
DOCKET NO. P56975

APPLICANT

JUNG-KEUN AHN, et al.

FILING DATE 3 November 2003

GROUP 1772



PATENT & TRADEMARK DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
✓	JP 2001-160360	6/01	JAPAN	—	—	Abstract	
✓	JP 2001-236890	8/01	JAPAN	—	—	Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

✓	Office Action from the Korean Industrial Property Office issued in Applicant's corresponding Korean Patent Application No. 10-2002-0068084 (dated 30 September 2004).		

EXAMINER: D. [Signature] DATE CONSIDERED: 10/14/05

EXAMINER: Initial if reference considered. Whether or not citation is in conformance with MPEP §609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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U.S. PATENT DOCUMENTS

EXAMINER	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
✓	RE37,444	11/01	Kanazawa	—	—	
✓	5,541,618	07/96	Shinoda	—	—	
✓	5,661,500	08/97	Shinoda et al.	—	—	
✓	5,663,741	09/97	Kanazawa	—	—	
✓	5,674,553	10/97	Shinoda et al.	—	—	
✓	5,724,054	03/98	Shinoda	—	—	
✓	5,786,794	07/98	Kishi et al.	—	—	
✓	5,952,782	09/99	Nanto	—	—	
✓	6,630,916	10/03	Shinoda	—	—	
✓	6,707,436	03/04	Setoguchi et al.	—	—	

FOREIGN PATENT DOCUMENTS

TRANSLATION

	DOCUMENT NUMBER	DATE	COUNTRY	CLAS	SUBCLASS	YES	NO
✓	JP 2001-325888	11/01	JAPAN	—	—	Abstract	
✓	JP 2001-043804	02/01	JAPAN	—	—	Abstract	
✓	JP 2917279	04/99					
✓	JP 02-148645	06/90	JAPAN	—	—	Abstract	
✓	JP 2845183	10/98					

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

✓ "Final Draft International Standard", Project No. 47C/61988-1/Ed.1; Plasma Display Panels - Part 1: Terminology and letter symbols, published by International Electrotechnical Commission, IEC. in 2003, and Appendix A - Description of Technology, Annex B - Relationship Between Voltage Terms And Discharge Characteristics; Annex C - Gaps and Annex D - Manufacturing

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	APPLICANT	<b>JUNG-KEUN AHN</b>
	FILING DATE	<b>3 November 2003</b>
		GROUP

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

## **TRANSLATION**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	YES	NO
	JP2001-160360	6/01	Japan				

✓ on  
105  
dated  
12/8/04

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**


EXAMINER: D. J. May

DATE CONSIDERED: 10/14/05

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